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# Thermodynamics

Thermodynamics of Defects

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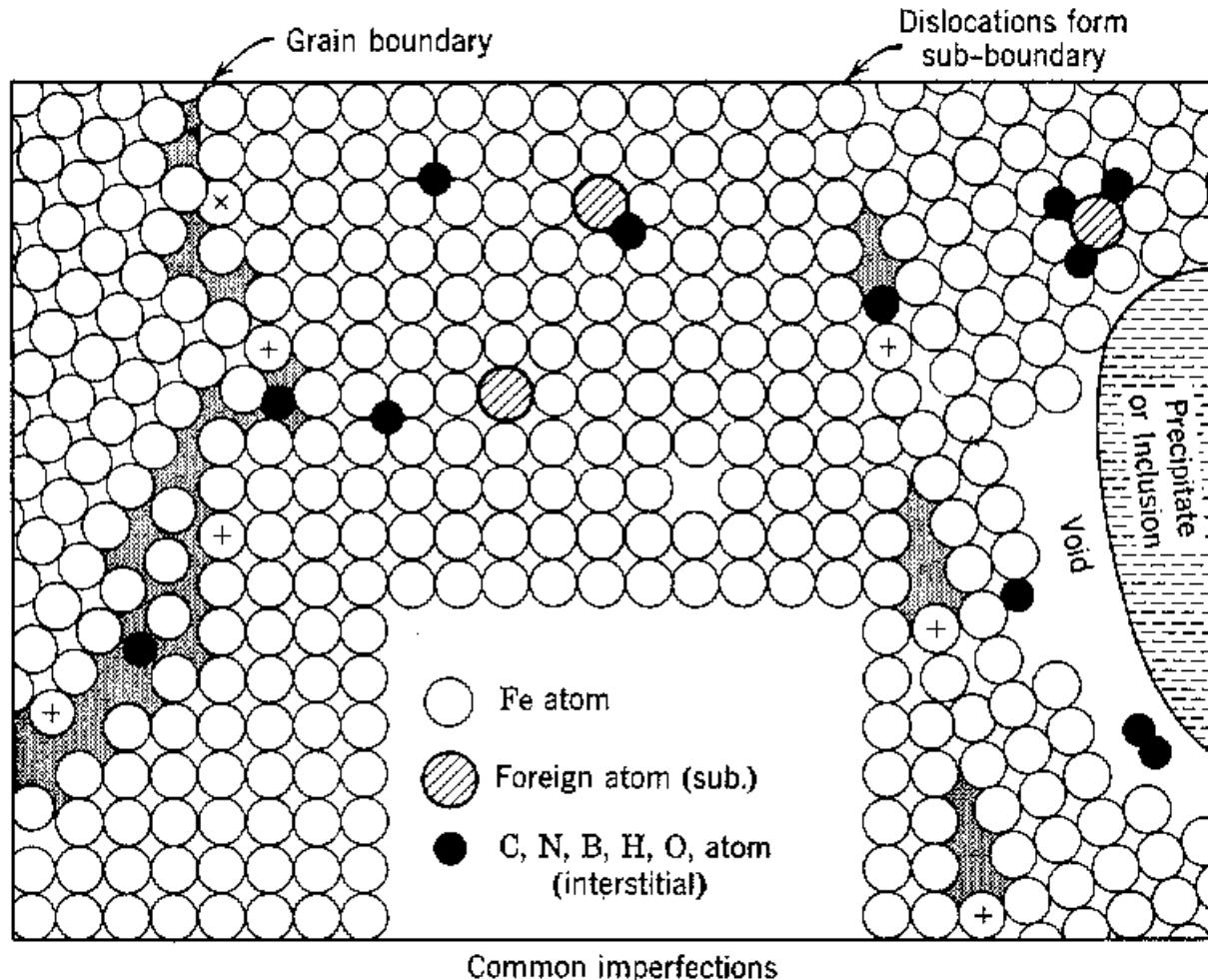
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## Defects and Defect Complexes in Metals – from L.S. Darken



## Scope

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### Role of Defects

1. Mechanical Properties
2. Kinetics of Phase Transformation
3. Electrical conductivity of Semi-conductors and ionic crystals
4. Luminescence Phenomena
5. Photoconductivity
6. Color

### Purpose of Defect Chemistry

1. Control of the concentrations of various defects
2. Control of the crystal properties related to defects



## Type of Defects

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### Point Defects

1. Atomic Defects
  - Vacancies
  - Interstitials
  - Impurities
  - Complexes

1. Electronic Defects

### Line Defects

- Dislocations

### Planar Defects

1. Surfaces
2. Interfaces



## Point Defect – Concentration

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### Statistical Approach

1. An occupied state                     $E = 0$
2. An unoccupied state                 $E = E_v$

$$P_v = \frac{e^{-E_v/kT}}{Z} = \frac{n}{n+N} = \frac{e^{-E_v/kT}}{1+e^{-E_v/kT}}$$
$$\frac{n}{N} = e^{-E_v/kT}$$

### Thermodynamic Approach

$$\Delta G = n\Delta H_v - T(\Delta S_v + \Delta S_c)$$

$$\Delta G = n(\Delta H_v - T\Delta S_v) - kT[(N+n)\ln(N+n) - N\ln N - n\ln n]$$

$$\frac{\partial \Delta G}{\partial n} = (\Delta H_v - T\Delta S_v) + kT \ln \frac{n}{N+n} = 0$$

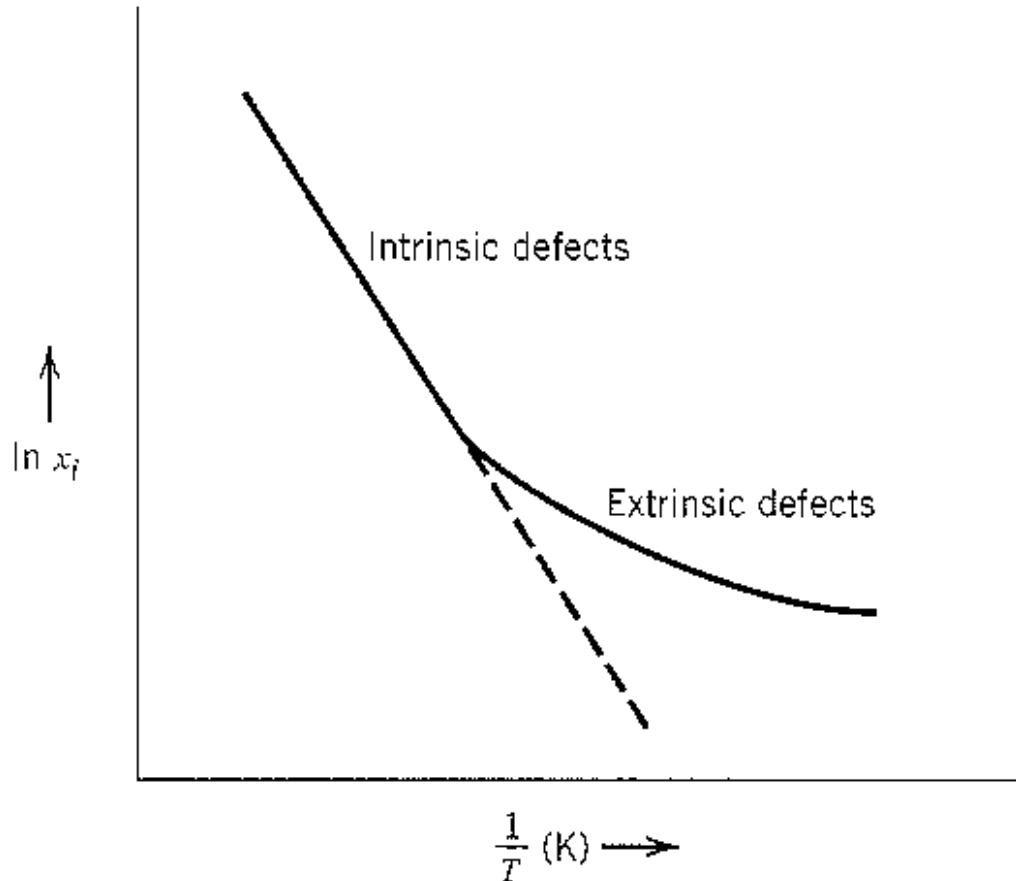
$$x_v = \frac{n}{N+n} = \exp\left(\frac{\Delta S_v}{k}\right) \exp\left(\frac{-\Delta H_v}{kT}\right) \quad x_d = A \exp\left(\frac{-\Delta H_d}{kT}\right)$$



## Point Defect – Intrinsic vs. Extrinsic

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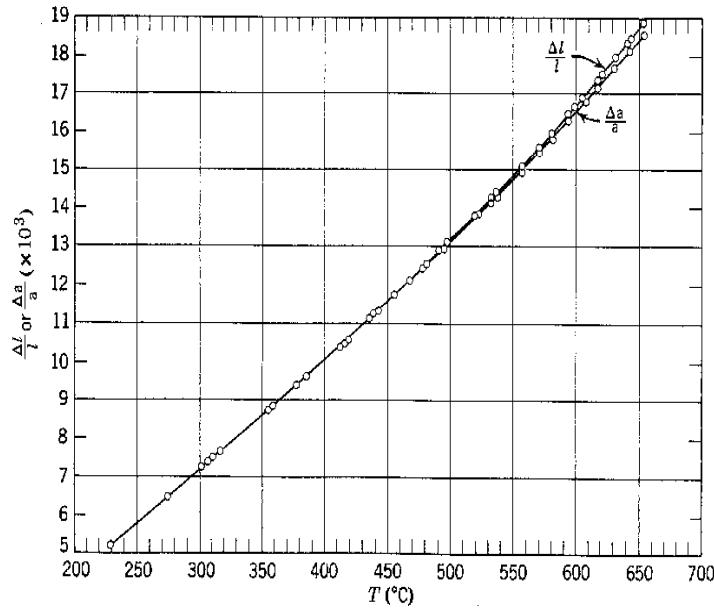
$$\ln x_d = \ln A - \left( \frac{\Delta H_d}{k} \right) \cdot \frac{1}{T}$$



## Point Defect – Measurements of vacancy formation energy

### Thermal expansion

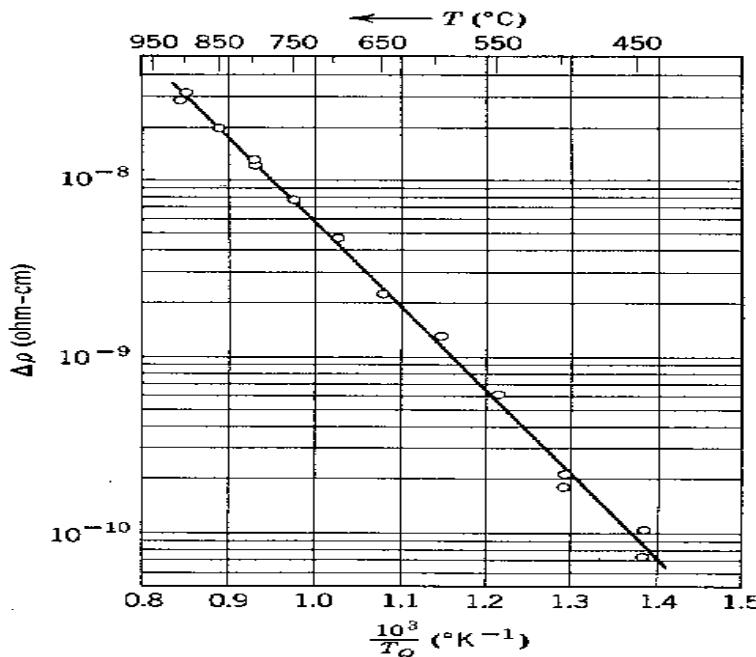
$$\frac{n_V}{N} = x_v = 3 \left( \frac{\Delta l}{l} - \frac{\Delta a}{a} \right)$$



Relative length and lattice parameter changes of aluminum as a function of temperature. From R. O. Simmons and R. W. Balluffi, *Phys. Rev.*, 117, 52 (1960).

### Temperature dependence of e-resistivity

$$\frac{\partial \ln(ax_v)}{\partial(1/T)} = -\frac{\Delta H_v}{k} = \frac{\partial \ln(\Delta\rho)}{\partial(1/T)}$$



J. E. Bauerle and J. S. Koehler, *Phys. Rev.*, 107, 1493 (1957)



## Point Defect – vacancy-impurity interaction

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$$n_v = n_v^{\text{int}} + n_{I-V}$$

Set  $E_v^{\text{int}} = 0$

$$E_{I-V} = E_{I-V}$$

$$\frac{n_{I-V}}{n_v^{\text{int}}} = \frac{g_{I-V} \exp\left(\frac{-E_{I-V}}{kT}\right)}{Z}$$

$$\frac{n_{I-V}}{n_v^{\text{int}}} = \frac{g_{I-V} \exp\left(\frac{-E_{I-V}}{kT}\right)}{g^{\text{int}} + g_{I-V} \exp\left(\frac{-E_{I-V}}{kT}\right)} = \frac{Zn_I \exp\left(\frac{-E_{I-V}}{kT}\right)}{N - n_I - Zn_I + Zn_I \exp\left(\frac{-E_{I-V}}{kT}\right)}$$

$$N \gg (Z+1)n_I$$

$$\frac{n_{I-V}}{n_v^{\text{int}}} = \frac{n_I}{N} Z \exp\left(\frac{-E_{I-V}}{kT}\right)$$

For  $n_I/N=1\%$  and  $E_{I-V}=-0.1\text{eV}$

$n_{I-V}/n_v^{\text{int}} = 0.63$  at 700K



## Point Defect – impurity-defect interaction (nitrogen/dislocation in Fe)

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$$n_N = n_N^{\text{int}} + n_{Nd}$$

Set  $E_N^{\text{int}} = 0$

$$E_{Nd} = E_{Nd}$$

$$\frac{n_{Nd}}{n_N^{\text{int}}} = \frac{g_{Nd} \exp\left(\frac{-E_{Nd}}{kT}\right)}{g_N^{\text{int}} + g_{Nd} \exp\left(\frac{-E_{Nd}}{kT}\right)} = \frac{g_{Nd} \exp\left(\frac{-E_{Nd}}{kT}\right)}{g_N^{\text{int}}} \quad \text{for } g_N^{\text{int}} \gg g_{Nd}$$

$$n_N = n_N^{\text{int}} \left( 1 + \frac{g_{Nd}}{g_N^{\text{int}}} \exp\left(\frac{-E_{Nd}}{kT}\right) \right)$$

For dislocation density =  $5 \times 10^{12} \text{ cm/cm}^3$

number of interstitial atoms =  $4.3 \times 10^7 / \text{cm}^3 (8.4 \times 10^{22})^{1/3}$

$E_{Nd} = -0.3 \text{ eV}$ , at 700K

$$n_N = 1.37 n_N^{\text{int}}$$



## Electronic Defect – electron/hole in conduction/balance band

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$$N_c = \int_{E_g}^{\infty} g(E) \left[ 1 + \exp\left(\frac{E - \mu}{kT}\right) \right]^{-1} dE$$

$$g(E) = 4\pi \left( \frac{2m_e^*}{h^2} \right)^{3/2} (E - E_g)^{1/2} = C_e (E - E_g)^{1/2} \quad g(E) = 4\pi \left( \frac{2m_h^*}{h^2} \right)^{3/2} (-E)^{1/2} = C_h (-E)^{1/2}$$

$$1 + \exp\left(\frac{E - E_F}{kT}\right) \approx \exp\left(\frac{E - E_F}{kT}\right) \quad \text{for} \quad (E - E_F) \gg kT$$

$$N_c = C_e \int_{E_g}^{\infty} (E - E_g)^{1/2} \exp\left(-\frac{E - E_F}{kT}\right) dE = C_e (kT)^{3/2} \exp\left(-\frac{E_g - E_F}{kT}\right) \int_0^{\infty} x^{1/2} e^{-x} dx$$
$$\int_0^{\infty} x^{1/2} e^{-x} dx = \frac{1}{2} \sqrt{\pi}$$

$$N_c = 2 \left( 2\pi \frac{m_e^* k T}{h^2} \right)^{3/2} \exp\left(-\frac{E_g - E_F}{kT}\right) \quad N_h = 2 \left( 2\pi \frac{m_h^* k T}{h^2} \right)^{3/2} \exp\left(-\frac{E_F}{kT}\right)$$

Intrinsic Semiconductor,  $N_c = N_h$

$$E_F = \frac{E_g}{2} + \frac{3}{4} kT \ln \frac{m_h^*}{m_e^*}$$

$$N_c N_h = 4 \left( \frac{2\pi k}{h^2} \right)^3 (m_e^* m_h^*)^{3/2} T^3 \exp\left(-\frac{E_g}{kT}\right) = N_c^2$$



## Defects in Stoichiometric Ionic Compounds – Kroger-Vink Notation

Symbol	Definition
M	Atom of electropositive element
X	Atom of electronegative element
$M_M$	M atom on M site (sometimes denoted as $M_M^X$ )
$N_M$	N atom on M site
$V_M$	Vacancy on M site
$M_i$	M atom on interstitial site
$M_i^+$	Positively charged M ion on interstitial site (singly ionized)
$M_i^{++}$	Positively charged M ion on interstitial site (doubly ionized)
$X'_i$	Negatively charged X ion on interstitial site (singly ionized)
$V_X'$	Positively charged vacancy (relative to perfect lattice) on X site
$V_M'$	Negatively charged vacancy (relative to perfect lattice) on M site

- 1. Electroneutrality**
- 2. Mass conservation**
- 3. Fixed Site ratio M:X**



## Defects in Stoichiometric Ionic Compounds – Frenkel defect

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$$M_M = M_i^* + V_M'$$

$$K_1 = \frac{a_{M_i^*} a_{V_M'}}{a_{M_M}} \cong [M_i^*][V_M']$$

$$\Delta G = n \Delta H_f - T (n \Delta S_f + \Delta S_c)$$

$$\Delta S_c = k \ln \left[ \frac{(N+n_v)!}{N! n_v!} \frac{(N+n_i)!}{N! n_i!} \right]$$

$$\left( \frac{n_v}{N+n_v} \right) \cdot \left( \frac{n_i}{N+n_i} \right) = \exp \left( \frac{\Delta S_f}{k} \right) \exp \left( - \frac{\Delta H_f}{kT} \right)$$

$$[M_i^*][V_M'] = \frac{N_A^2}{V^2} \exp \left( \frac{\Delta S_f}{k} \right) \exp \left( - \frac{\Delta H_f}{kT} \right)$$



## Defects in Stoichiometric Ionic Compounds – Schottky-Wagner defect

$$null = V_X^* + V_M^{'}$$

$$K_2 = [V_X^*][V_M^{'}]$$

### Coexistence of Frenkel and Schottky-Wagner defects

$$[V_M^{'}] = [M_i^*] + [V_X^*]$$

$$K_1 = [M_i^*][V_M^{'}]$$

$$K_2 = [V_X^*][V_M^{'}]$$

$$K_1 + K_2 = ([M_i^*] + [V_X^*])[V_M^{'}] = [V_M^{'}]^2$$



## Defects in Stoichiometric Compounds – Interactions among defects

### Between MX and M gas

$$M(g) = M_i^* + n'$$

$$K_F = \frac{[M_i^*][n']}{P_M}$$

$$\ln K_F = \ln[M_i^*] + \ln[n'] - \ln P_M$$

$$M_M = M_i^* + V_M'$$

$$K_F' = [M_i^*][V_M']$$

$$\ln K_F' = \ln[M_i^*] + \ln[V_M']$$

$$null = n' + p^*$$

$$k_i = [n'][p^*]$$

$$\ln K_i = \ln[n'] + \ln[p^*]$$

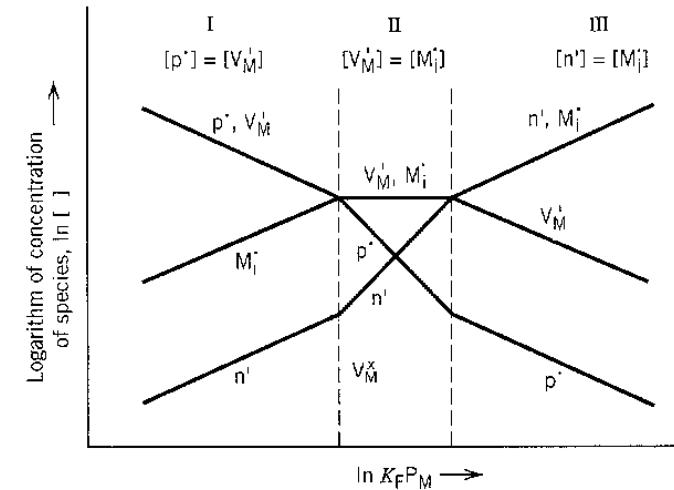
Electroneutrality

$$[n'] + [V_M'] = [p^*] + [M_i^*]$$

Low  $P_M$   
high  $P_M$   
in between

$$\begin{aligned} [p^*] &= [V_M'] \\ [n'] &= [M_i^*] \\ [M_i^*] &= [V_M'] \end{aligned}$$

$$2\ln[p^*] = -\ln K_F P_M + \ln K_F' K_i$$

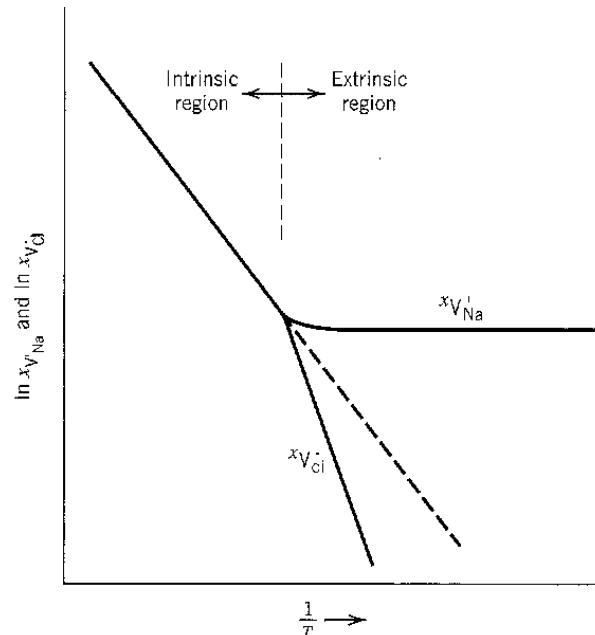


## Defects in Stoichiometric Compounds – Intrinsic/Extrinsic defects

### Dilute solution of CdCl<sub>2</sub> in NaCl

$$K_S = [V'_{Na}][V^*_{Cl}]$$

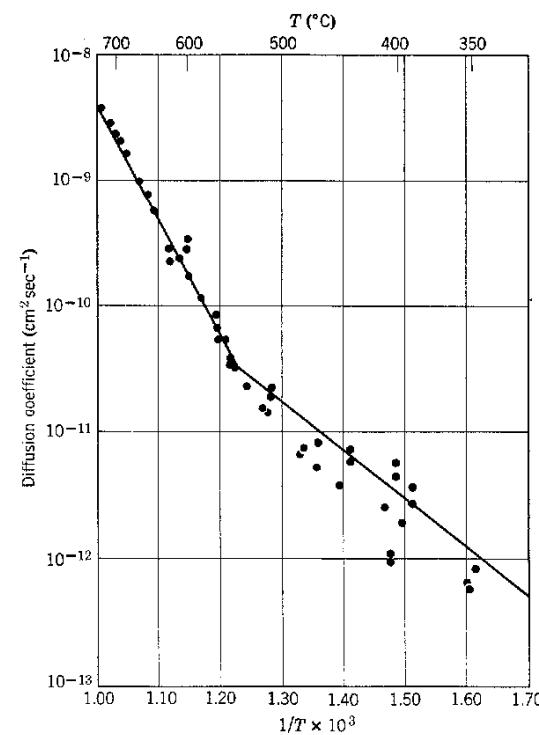
$$[V'_{Na}] = \frac{[Cd^*_{Na}] + ([Cd^*_{Na}]^2 + 4K_S)^{1/2}}{2}$$



$$[V'_{Na}] = [Cd^*_{Na}] + [V^*_{Cl}]$$

$$[V'_{Na}] = [Cd^*_{Na}] + \frac{K_S}{[V'_{Na}]}$$

$$[V'_{Na}]^2 - [Cd^*_{Na}][V'_{Na}] - K_S = 0$$



## Defects in Stoichiometric Compounds – Determination of defect type

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Density and Lattice parameter measurement: CaO doped ZrO<sub>2</sub>

for 15mol% CaO : Zr<sub>0.85</sub>Ca<sub>0.15</sub>O<sub>1.85</sub>

- Vacancy in Oxygen site
- Interstitial Cation

Measured lattice parameter: 5.131Å (CaF<sub>2</sub> structure)

→ volume of unit cell:  $135.08 \times 10^{-24} \text{ cm}^3$

Mass of unit cell

$$1. \quad 4 \times (0.15 \times 40.08 + 0.85 \times 91.22 + 1.85 \times 16) / N_A = 452.60 / N_A \\ \rightarrow \text{density} = 5.57 \text{ g/cm}^3$$

$$2. \quad 4 \times (0.15 \times 40.08 \times (2/1.85) + 0.85 \times 91.22 \times (2/1.85) + 2 \times 16) / N_A \\ = 489.29 / N_A \quad \rightarrow \text{density} = 6.01 \text{ g/cm}^3$$

※ Experimentally measured density is close to 5.57

→ useful as oxide ion conductors in high temperature fuel cells  
and as oxygen pressure sensors in electrochemical cells



## Defects in Stoichiometric Compounds – Determination of defect type

Electrical conductivity measurement:

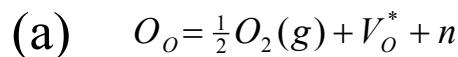
ZnO becomes conductive if heated at low oxygen pressure

Experiments show: ZnO is an n-type semiconductor

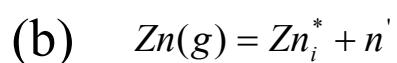
$$\text{and } \sigma \approx [n'] \approx P_{O_2}^{-1/4}$$

Two possibilities

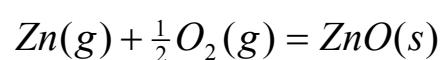
- (a) Formation of anion vacancies:
- (b) Formation of cation interstitials



$$K_a = p_{O_2}^{1/2} \cdot [V_O^*][n']$$



$$K_b = \frac{[Zn_i^*][n']}{p_{Zn}}$$



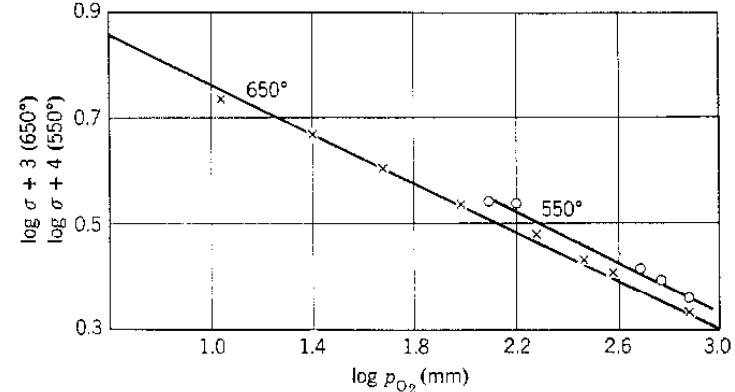
$$K = p_{Zn} \cdot p_{O_2}^{1/2}$$

$$K_b K = [Zn_i^*][n'] \cdot p_{O_2}^{1/2}$$

$$[Zn_i^*] = [n']$$

$$\sigma \cong [n'] \cong p_{O_2}^{-1/4}$$

※ Fast diffusion of Zn in ZnO support (b)



## Example – Effect of impurity elements on the Oxidation rate of Zn

